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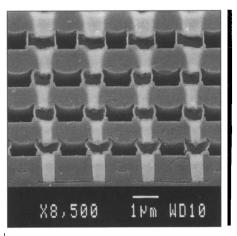
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ON THE COVER: Hydrogen silsesquioxane (HSQ) has been successfully integrated into a five-level W-plug multilevel interconnect technology. This figure represents a scanningelectron-microscopy cross section showing a pentalevel W-plug and low-dielectric-constant (k) HSQ interconnect system. The low-k HSQ appears as the dark regions between the metal lines while the W-plugs appear as the bright regions connecting metal lines. Provided by G. Dixit, Texas Instruments, Inc. For more information, see "Integration of Low-k Dielectric Materials into Sub-0.25- μ m Interconnects" by R.S. List, A. Singh, A. Ralston, and G. Dixit on p. 61 of this issue.

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